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Docket No. 4653/PDC/V

IN THE UNITED STATES PATENT AND TRADEMARK OFFICE

Patent Application
Assistant Commissioner for Patents
Washington, D.C. 20231

Re: Inventor(s): Daniel I. SOME; Silviu REINHORN; Gilad ALMOGY
Title: LASER SCANNING WAFER INSPECTION USING NONLINEAR OPTICAL PHENOMENA

Transmitted herewith is the patent application identified above, including:

- ☒ Specification, claims and abstract, totaling 17 pages.
- ☒ Drawings totaling 4 pages, Formal ☒ Informal.
- ☒ Executed Declaration and Power of Attorney.
- ☒ Assignment of the invention to Applied Materials, Inc.
- ☒ Assignment Recordation Cover Sheet
- ☒ Information Disclosure Statement, Form PTO-1449 and references

FEE CALCULATION					
Fee Items	Claims Filed	Included With Basic Fee	Extra Claims	Fee Rate	Total
Total Claims	-34-	- 20 =	-14-	X \$18.00	-\$252.00-
Independent Claims	-3-	- 3 =	-0-	X \$78.00	-0-
Basic Filing Fee				\$710.00	\$710.00
TOTAL FEES					\$962.00

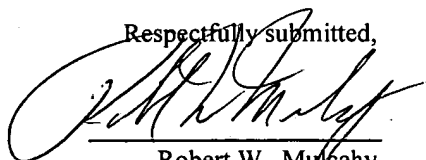
- ☒ The Commissioner is hereby authorized to charge \$962.00 to Deposit Account No 50-1074
- ☒ The Commissioner is hereby authorized to charge any additional fees which may be required, or credit any overpayment to Deposit Account No. 50-1074. A duplicate copy of this transmittal is enclosed.
- ☒ Please address all future correspondence to:
**PATENT COUNSEL
APPLIED MATERIALS, INC.
Legal Affairs Department
P.O.BOX 450A
Santa Clara, CA. 95052**

I hereby certify that this correspondence is being deposited with the United States Postal Service as express mail in an envelope addressed to: Box Patent Application, Assistant Commissioner for Patents, Washington, D.C. 20231.

Express Mail Receipt No. EL66180554745

Date of Deposit 2-14-2001

Signature Boa Mulahy

Respectfully submitted,

Robert W. Mulcahy
Registration No. 25,436